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	To the Honorable Commissioner of Pater.	100811404	ched original documents or copy thereof.				
מ און	1. Name of conveying party(ies) Shi-Woo Rhee, Jong-Ho Yur	2. Name and add Name: n Internal Address:	Postech Foundation				
	Additional name(s) of conveying party(YesX No	Street Address:	San 31, Hyoja-dong, Nam-gu, Pohang-shi, Kyungsanbuk-do 7994784				
	X Assignment Security Agreement Merger Change of Name Other	City: Additional name(s	Republic of Korea				
	Execution Date: <u>July 21, 1998</u> .						
	4. Application number(s) or patent number	(s): 09/139701					
If this document is being filed together with a new application, the execution date of the application is: <u>July 21, 1998</u> .							
	A. Patent Application No.(s)	B. Patent	No.(s)				
	Additional numbers attached? Yes _X No						
	Name and address of party to whom corrections document should be mailed:	espondence 6. Total number patents invo	6. Total number of applications and patents involved				
	Name: Internal Address: ANDERSON, KILL & OLICK, F Street Address: 1251 Avenue of the Americ 44th Floor City: NEW YORK State: N.Y. Z	cas 8. Deposit acco	CFR 3.41)				
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1	FC:581 40.00 CH Public burden reporting for this sample covincluding time for reviewing the document and comments regarding this burden estimate PK2-1000C, Washington, D.C. 20231, and to to Washington, D.C. 20503.	Washington, D.C. 20231 ver sheet is estimated to average about and gathering the data needed, and complete to the U.S. Patent and Trademark Off	leting and reviewing the sample cover sheet. ice, Office of Information Systems,				

NY2-113921.1

ASSIGNMENT

WHEREAS, WE, Shi-Woo RHEE; and Jong-Ho YUN, ASSIGNORS, citizens of Republic of Korea, residing at Kyosu Apt. 9-803, #756, Jigok-dong, Nam-gu, Pohang-shi, Kyungsangbuk-do 790-390, Korea; and San 31, Hyoja-dong, Nam-gu, Pohang-shi, Kyungsangbuk-do 790-784, Korea, respectively, are the inventors of the invention in

PROCESS FOR SELECTIVE METAL DEPOSITION IN HOLES OF SEMICONDUCTOR DEVICE

for which We have executed an application for a Patent of the United States

	which is executed on					
a	which is identified by Anders		-		'	
0	which was filed on	, Seria	l No	··		
	EREAS, POSTECH FOUNDA E, is desirous of obtaining th					
and by the and assignment and extended to the and extended together application other into all forms	NOW, THEREFORE, in consistion, the receipt of which is hiese presents do hereby sell, gns, the entire right, title and renewals and continuations as a siconsthereof; and all applicated and designs which may with the right to file such application under the Patent Laws of the principle of industrial property protect ay be granted for said inventithereof;	ereby acknowledge assign, transfer ar interest in, to and thereof, and all Pa ions for industrial p hereafter be filed ications and the rig the United States, the compestic laws of the ion, including, with	ed, we, the said and set over, unto under the said tents of the Uniproperty protecting the said invention of the Uniproperty protecting the claim for the International ecountry in whichout limitation,	ASSIGNORS, have so the said ASSIGNED invention, and the ted States which moon, including, without on in any country or the same the priority Convention for the ch any such applicate patents, utility model.	old, assigned, transfer E, its successors, lega said United States ap ay be granted thereon at limitation, all applica countries foreign to the rights derived from sa Protection of Industrial tion is filed, as may be els, inventors' certifica	red and set over, representatives plication and all and all reissues tions for patents, re United States, id United States Property, or any applicable; and tes and designs
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have not	AND WE HEREBY covenant executed, and will not execu				interest herein assigr	ed, and that we
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	IN TESTIMONY WHEREOF, Y	We hereunto set ou	ir hands and sea	als the day and year	set opposite our respe	ctive signatures.
Date	July 21	, 1998	Shi	ado Rh	00	L.\$.
Date	July 21	, 1998	Jan	s to y	m-	L.S.